

INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

October 13, 2024

IGI Report Number

Description

Shape and Cutting Style

Measurements

LG659464837

LABORATORY GROWN DIAMOND

CUT CORNERED RECTANGULAR MODIFIED BRILLIANT

9.67 X 6.72 X 4.23 MM

GRADING RESULTS

Carat Weight

Color Grade

Clarity Grade

2.42 CARATS

E

VS 2

ADDITIONAL GRADING INFORMATION

Polish

Symmetry

Fluorescence

EXCELLENT

EXCELLENT

NONE

Inscription(s)

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

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PROPORTIONS

Medium To Slightly Thick

13.5%

45%

63%

62.9%

Pointed

Sample Image Used

CLARITY CHARACTERISTICS

KEY TO SYMBOLS

Red symbols indicate internal characteristics.

Green symbols indicate external characteristics.

COLOR

D

E

F

G

H

I

J

Faint

Very Light

Light

CLARITY

IF

VVS¹⁻²

VS¹⁻²

SI¹⁻²

I¹⁻³

Internally Flawless

Very Very Slightly Included

Very Slightly Included

Slightly Included

Included

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October 13, 2024

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CUT CORNERED RECT. MODIFIED BRILLIANT

9.67 X 6.72 X 4.23 MM

Carat Weight

Color Grade

Clarity Grade

Depth

Table

Girdle

Medium to Slightly Thick

Pointed

Polish

Symmetry

Fluorescence

Inscription(s)

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2.42 CARATS

E

VS 2

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